

Application/Control No.	Applicant(s)/Patent under Reexamination
10/580,681	GENMA ET AL.
Examiner	Art Unit
Son T. Nauven	3643

SEARCHED					
Class	Subclass	Date	Examiner		
47	67 83	3/19/2009	STN		
	85 87				
	66.1 66.5				

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
47	67 83	3/20/2009	STN		
	87 66.5	3/20/2009	STN		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
IPC foreign search, see printouts	3/19/2009	STN		
text search, see printouts	3/19/2009	STN		
interference claim text search, see printouts	3/20/2009	STN		